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Title: Method for growing *carbon nanowalls*



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Die folgenden Angaben sind den vom Anmelder eingereichten Unterlagen entnommen

- 54 Mikroelektronik durch Teilchenstrahltechnik
- 57 Zur Herstellung von Transistorelektronik im Längenbereich unterhalb der optischen bis ultravioletten Wellenlängen werden Elektronen-, Ionen- und Neutralstrahltechniken angewendet in Kombination mit lasergeriebenen Teilchenstrahlquellen.

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Receipt is acknowledged of this non-provisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please submit a written request for a Filing Receipt Correction. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections.

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Foreign Applications (You may be eligible to benefit from the Patent Prosecution Highway program at the USPTO. Please see <http://www.uspto.gov> for more information.)

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